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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Hidefumi NAKATA

Date: March 4, 2002

Serial No.: 09/989,962

Group Art Unit: ----

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ltr.  
with  
Formal  
Drawings  
10-7-02  
R. [signature]

For: **MIM CAPACITOR AND MANUFACTURING METHOD THEREFOR**

Assistant Commissioner for Patents  
Washington, DC 20231

Attention: **Official Draftsperson**

**FORMAL DRAWINGS**

Sir:

Enclosed herewith please find three (3) sheets of formal drawings containing Figures 1-4D for the above-identified application.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 4, 2002:

Respectfully submitted,

Martin Pfeffer  
Name of applicant, assignee or  
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